



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 20, 2026	
IGI Report Number	LG783610245
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	6.93 X 6.91 X 5.02 MM

GRADING RESULTS

Carat Weight	2.07 CARATS
Color Grade	F
Clarity Grade	VS 1

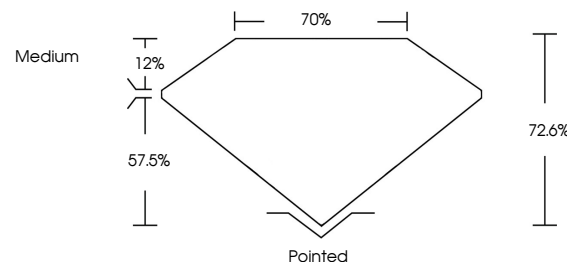
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG783610245

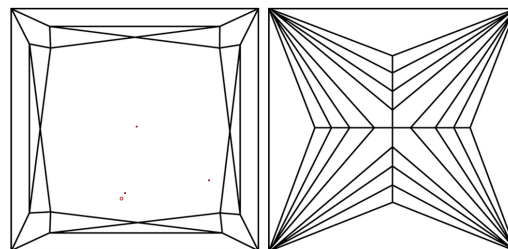
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG783610245
Report verification at lgi.org

PROPORTIONS

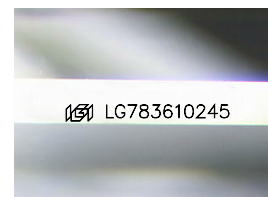


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

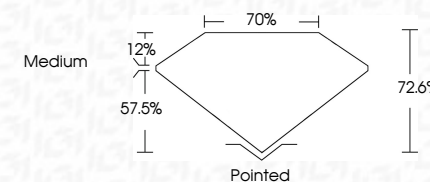
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March 20, 2026
GI Report No LG783610245
PRINCESS CLIT

2.07 CARATS	F	VS 1	72.6%	70%	Medium	Pointed	EXCELLENT	EXCELLENT	NONE
Carat Weight	Color Grade	Clarity Grade	Depth	Table	Grade	Culet	Polish	Symmetry	Fluorescence

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(CVD) growth process.

www.igi.org